

Attorney's Docket No.: 42P17282

Confirmation No.: 9154

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Hok-Kin Choi, et al.

Application No. 10/750,199

Filed: 12/30/2003

For: A METHOD TO ASSAY SACRIFICIAL LIGHT ABSORBING MATERIALS AND SPIN ON GLASS MATERIALS FOR CHEMICAL ORIGIN OF DEFECTIVITY Examiner: Not yet assigned

Art Unit:

2856

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, V.A. 22313-

Date/

dy V. Steinkraus

MS: Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Office Action dated September 1, 2005 for the above-identified application, Applicants respectfully request the Examiner to consider the following remarks.

Remarks

Applicant respectfully requests consideration of this application. The Office

Action required restriction to one of the following inventions under 35 U.S.C. § 121:

1. Claims 1 - 17; and

11. Claims 18 - 26.

Applicant elects Group I, claims 1 - 17. Upon the allowance of a generic claim,

applicant will be entitled to consideration of claims to additional species which are written

in dependent form or otherwise include all the limitations of an allowed generic claim as

provided by 37 C.F.R. 1.141.

If the Examiner believes a telephone interview would expedite the prosecution of

this application, the Examiner is invited to contact Suk Lee at (408) 720-8300.

If there are any additional charges, please charge them to Deposit Account No. 02-2666.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Date: 13 September 2005

Lee

Attorney for Applicants

Reg. No. 47,745

12400 Wilshire Blvd. Seventh Floor

Los Angeles, CA 90025-1030

(408) 720-8300